# Supplemental information

# Mathematical Model Based on Staircase Structure for Porous Electrode Impedance

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#### **General theory for resistance and capacitance in AC impedance**

When given the voltage  $(E)$  and current  $(I)$  as a function of AC frequency  $(\omega)$ , the impedance component  $(Z(\omega))$  respectively, can be shown as follows <sup>1, 2</sup>:

$$
Z(\omega) = \frac{E(\omega)}{I(\omega)}\tag{1}
$$

where  $\omega$  (=  $2\pi f$ , *f* is the frequency (Hz)) is the angular velocity.

Here, resistance and capacitance as impedance component are considered  $(Z_R \text{ and } Z_C)$ respectively).

*Z*<sub>R</sub>, consisting of resistance (*R*), can be expressed by the relation *E*(ω) = *RI*(ω), as in the following equation:

$$
Z_R = R \tag{2}
$$

This equation is not affected by AC frequency.

On the other hand, the current  $I(\omega)$  in the presence of electric double layer capacitance (*C*<sub>dl</sub>) can be shown as the following equation using the relation  $Q = C_dE(\omega)$  when charge (*Q*) is differentiated with time (*t*):

$$
I(\omega) = \frac{dQ}{dt} = C_{dl} \frac{\partial E(\omega)}{\partial t}
$$
 (3)

The time derivative of  $E(\omega)$  in AC results in  $j\omega E(\omega)$ , so  $I(\omega) = j\omega CE(\omega)$ . Therefore,  $Z_C$ can be shown as follows:

$$
Z_c = (j\omega C_{dl})^{-1} \tag{4}
$$

where *j* is an imaginary number. This equation is affected by AC frequency.

These are used as impedance components for equivalent circuit design.

#### **Complex capacitance theory**

Impedance  $(Z(\omega))$  and complex capacitance  $(C(\omega))$  are related as follows <sup>3, 4</sup>.

$$
C(\omega) = \frac{1}{j\omega Z(\omega)}\tag{5}
$$

Based on the definition of complex impedance  $(Z(\omega) = Z_{re} + jZ_{im})$ , the complex capacitance  $(C(\omega) = C_{re} + jC_{im})$  is considered as follows.

$$
C(\omega) = \frac{1}{j\omega(Z_{re} + jZ_{im})}
$$
\n<sup>(6)</sup>

Here, the real  $(C_{re})$  and the imaginary  $(C_{im})$  parts are expressed as follows.

$$
C_{re} = \frac{-Z_{im}}{\omega |Z(\omega)|^2}
$$
 (7)

$$
C_{im} = \frac{Z_{re}}{\omega |Z(\omega)|^2}
$$
 (8)

## **Program details Program for Python for impedance spectra of non-Faradaic process in a staircase model**

import numpy as np # importing modules for using NumPy import pandas as pd # importing modules for using Pandas import cmath # importing modules for using imaginary number import math # importing modules for using pi

# input parameters

 $Re = 0.001$  # input electric resistance  $Rion = 0.03$  # input ionic resistance  $C = 0.001$  # input electric double-layer capacitance

# setting the frequency

 $a = np.arange(91)$  # generating an isoperimetric sequence f =  $10^{**}(a/10 - 3)$  # frequency range:  $10^{(-3)}$  + 10<sup> $(-3)$ </sup> Hz  $w = 2$  \* math.pi \* f # angular velocity

# setting the capacitance jwc =  $w * C * 1j \# The notation "1j" is used to handle imaginary numbers in Python$ 

# Calculation of impedance using recursive function

 $i = 100$  # number of step def  $z$   $n(i)$ :  $if i < 1:$ return Rion + (Re +  $1$ /jwc) # i=0 return Rion +  $(1/(1/z \text{ n}(i-1) + 1/(Re + 1/\text{jwc}))) \# i>1$ ans  $n = z$   $n(i)$ 

 $Rre = ans$  n.real - Rion # Real part of impedance

 $Rim = -ans$  n.imag # Imaginary part of impedance

# output data

df non faradaic = pd.DataFrame(list(zip(w, Rre, Rim)), columns = ["Frequency (Hz)", "Rre n-f", "Rim\_n-f"])

df\_non\_faradaic

### **Program for Python for impedance spectra of Faradaic process in a staircase model**

import numpy as np # importing modules for using NumPy import pandas as pd # importing modules for using Pandas import cmath # importing modules for using imaginary number import math # importing modules for using pi

# input parameters

 $Re = 0.001$  # input electric resistance  $Rion = 0.03$  # input ionic resistance  $Ret = 400$  # input charge-transfer resistance  $C = 0.001$  # input electric double-layer capacitance

# setting the frequency

 $a = np.arange(91)$  # generating an isoperimetric sequence

f =  $10^{**}(a/10 - 3)$  # frequency range:  $10^{\circ} - 3 \sim 10^{\circ} + 3$  Hz

 $w = 2$  \* math.pi \* f # angular velocity

# setting the capacitance

jwc = w  $^*C^*1$  i # The notation "1j" is used to handle imaginary numbers in Python

# Calculation of impedance using recursive function

 $i = 100$  # number of step

def  $z$   $f(i)$ :

 $if i < 1:$ 

return Rion + (Re +  $1/(1/Ret + jwc)$ ) # i=0

return Rion +  $(1/(1/z \text{ f(i-1)} + 1/(Re + 1/(1/Ret + iwc))))$  # i>1

ans  $f = z$   $f(i)$ 

 $Rre = ans$  f.real - Rion # Real part of impedance

 $Rim = -ans$  f.imag # Imaginary part of impedance

# output data

df faradaic = pd.DataFrame(list(zip(w, Rre, Rim)), columns = ["Frequency (Hz)", "Rre f",

"Rim\_f"])

df faradaic



**Fig. S1** Nyquist plots of non-Faradaic and Faradaic processes in the transmission line model calculated using Equations (6) and (7). Input parameters:  $2\pi r = 1$  cm,  $L = 1$  cm,  $R_{\text{sol}} = 0 \ \Omega$ ,  $R_{\text{ion}, L} = 300 \ \Omega \text{ cm}^{-1}$ ,  $R_{\text{ct, A}} = 400 \ \Omega \text{ cm}^2$ ,  $C_{\text{dl, A}} = 0.1 \text{ mF cm}^{-2}$ .



Fig. S2 (a-e) Nyquist plots, and frequency properties of (f-j) absolute value of resistance  $(|Z|)$ , (k-o) the real part  $(C_{\text{re}})$ , and (p-t) imaginary part  $(C_{\text{im}})$  of complex capacitance for non-Faradaic processes at step numbers  $(n) = 0, 1, 2, 5$  and 10 calculated using the staircase model. Input parameters:  $R_{e, in} = 1 \text{ m}\Omega$ ,  $R_{ion, in} = 0.1 \Omega$ , and  $C_{dl, in} = 1 \text{ mF}$ . The calculation results of the frequency characteristics of the capacitance in non-Faradaic process obtained using the complex capacitance theory<sup>3, 4</sup> show that as *n* is increased,  $C_{\text{re}}$ reaching at the low frequency region increases, while the peak of the capacitance behaviour of *C*im shifts to the low frequency. These capacitance behaviours are typical of non-Faradaic process, and are in good agreement with the behaviour when the electrode thickness is increased. 3



Fig. S3 (a-e) Nyquist plots, and frequency properties of (f-j) absolute value of resistance (|Z|), (k-o) the real part (*C*re), and (p-t) imaginary part (*C*im) of complex capacitance for Faradaic processes at  $n = 0, 1, 2, 5$  and 10 calculated using the staircase model. Input parameters:  $R_{\rm e, in} = 1 \text{ m}\Omega$ ,  $R_{\rm ion, in} = 0.1 \Omega$ ,  $R_{\rm ct, in} = 100 \Omega$ , and  $C_{\rm dl, in} = 1 \text{ mF}$ . In Faradaic process, although *C*re shows similar behaviour to that of the non-Faradaic process, *C*im shows a tail toward the low frequency region without a peak. The value of *C*im for Faradaic process is about two orders of magnitude larger than that for the non-Faradaic process, which is in good agreement with the behaviour reflecting the effect of the current corresponding to Faradaic process. 5



**Fig. S4** (a-h) Detailed change in the Nyquist plots of non-Faradaic process in the high-frequency region for different *n* calculated using the staircase model. (i) Variation in the slope and coefficient of determination  $(R^2)$  of the linear approximation in the high-frequency region of the Nyquist plots for non-Faradaic process *vs*. the number of steps. Input parameters:  $n = 1-100$ ,  $R_{e, in} = 1$  m $\Omega$ ,  $R_{ion, in} = 10$  $\Omega$ , and  $C_{\text{dl, in}} = 1 \text{ mF.}$ 



**Fig. S5** Nyquist plots of non-Faradaic processes for each *R*ion, in at *n* = 50, 75, and 100 calculated using the staircase model. Input parameters:  $R_{e, in} = 1 \text{ m}\Omega$ ,  $R_{ion, in} = 1-10 \Omega$ , and  $C_{\text{dl, in}} = 1$  mF.



**Fig. S6** Nyquist plots of Faradaic processes for each *R*ct, in at *n* = 50, 75 and 100 calculated using the staircase model. Input parameters:  $R_{e, in} = 1 \text{ m}\Omega$ ,  $R_{ion, in} = 2 \Omega$ ,  $R_{ct, in} = 9-90 \text{ k}\Omega$ , and  $C_{\text{dl, in}} = 1$  mF.



<span id="page-10-0"></span>**Fig. S7** (a) Nyquist plots, (b) Absolute value of resistance (|Z|), (c) Real part (*C*re), and (d) Imaginary part (*C*im) of complex capacitance for symmetric cells using two positive electrodes in 1.0 M LiPF<sub>6</sub> in EC/DMC/EMC (30/40/40 volume ratio) at 20 °C. The positive electrode composition was LiNi0.75Co0.15Al0.05Mg0.05O2, carbon black, and PVDF at C = 1% (98/1/1), C = 2% (96/2/2), C = 3.5% (94/4/2), C = 10% (85/10/5), C = 15% (80/15/5) (weight ratio). Loading weight: ~10.5 mg cm<sup>−</sup><sup>2</sup> . Electrodes were uncharged (state of charge  $= 0\%$ ).



Fig. S8 Dependence of the absolute value of resistance (|Z|) on the conducting carbon ratio at frequencies of  $10^3$ ,  $10^1$ , and  $10^{-1}$  Hz for electrochemical impedance spectroscopy measured using the same symmetric cell as in **[Fig. S7](#page-10-0)**(b). With respect to the ratio of conductive carbon, |Z| at low frequencies of  $10^{-2}$  Hz shows linearity, while that at high frequencies of  $10<sup>1</sup>$  and  $10<sup>3</sup>$  Hz show nonlinearity. This suggests that the behavior in the high frequency region due to the electronic resistance is independent of the ratio of the conducting carbon.



**Fig. S9** Dependence of (a) the maximum value of the real part (*C*re. max) and (b) the frequency showing the maximum value of the imaginary part ( $f$   $@$   $C$ <sub>im, max</sub>) in the complex capacitance results measured using the same symmetric cell as shown in **[Fig. S7](#page-10-0)**(c) and d, respectively, on the conducting carbon ratio. These relationships mean that *C*re. max and *f* @ *C*im, max show linear variation at all conductive carbon ratios.



**Fig. S10** (a) Nyquist plots, (b) Absolute value of resistance (|Z|), (c) Real part (*C*re), and (d) Imaginary part (*C*im) of complex capacitance for non-Faradaic processes when electronic resistance is varied uniformly using the staircase model defined as (i) uniform change in Fig. 7(c). Input parameters:  $n = 100$ ,  $R_{e, in} = 0.3$  m $\Omega$ -30  $\Omega$ ,  $R_{ion, in} = 30$  m $\Omega$ , and *C*<sub>dl, in</sub> = 5  $\mu$ F.



<span id="page-14-0"></span>**Fig. S11** (a) Nyquist plots, (b) Absolute value of resistance (|Z|), (c) Real part (*C*re), and (d) Imaginary part (*C*im) of complex capacitance for non-Faradaic processes when electronic resistance is varied non-uniformly using the staircase model defined as (ii) nonuniform change A in Fig. 7(c). Input parameters:  $n = 100$ , Electronic resistance ( $R_e$ ) for deep/shallow regions =  $R_{e, high}/R_{e, low}$  (5/95 to 95/5),  $R_{e, high}$  = 90  $\Omega$ ,  $R_{e, low}$  = 30 m $\Omega$ ,  $R_{ion, in}$  $= 30$  mΩ, and  $C<sub>dl, in</sub> = 5$  µF.



**Fig. S12** (A) Nyquist plots, (B) Absolute value of resistance (|Z|), (C) Real part (*C*re), and (D) Imaginary part (*C*im) of complex capacitance for non-Faradaic processes when electronic resistance is varied non-uniformly using the staircase model defined as (iii) non-uniform change B in Fig. 7(c). Input parameters:  $n = 100$ , Electronic resistance  $(R_e)$ for deep/shallow regions =  $R_{\text{e, low}}/R_{\text{e, high}}$  (95/5 to 5/95),  $R_{\text{e, high}} = 90 \Omega$ ,  $R_{\text{e, low}} = 30 \text{ m}\Omega$ ,  $R_{\text{ion, in}} = 30 \text{ m}\Omega$ , and  $C_{\text{dl, in}} = 5 \mu\text{F}$ .



**Fig. S13** (i) Nyquist plot, (ii) Absolute value of resistance (|Z|), (iii) Real part (*C*re), and (iv) Imaginary part (*C*im) of complex capacitance (a) from the actual experimental result of symmetric cells using positive electrode with low carbon of 1% in **[Fig. S7](#page-10-0)**, and (b) from the calculated result using staircase modes obtained from the condition of nonuniform A at  $R_{e, high}$  ratio from deep = 95% in **[Fig. S11](#page-14-0)**. Both results show good agreement in the shape similarity in the Nyquist plot from 100 kHz–1 kHz and in the frequency response.

#### **References**

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